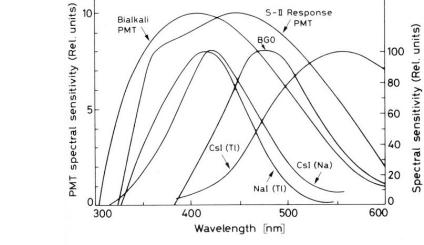
# 7. Scintillators, Photomultiplier and Time measurements

- 7.1 Principle of scintillators
- 7.2 Inorganic scintillators
- 7.3 Organic scintillators
- 7.4 Photomultiplier
- 7.5 Applications in detector systems
- 7.6 New devices: Avalanche Photo Diodes
  - Silicon Photomultiplier

#### Figures to Chapter 7.2

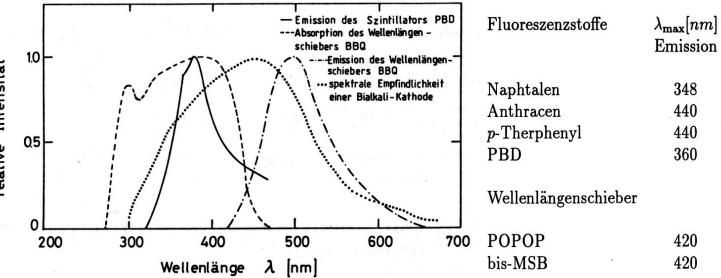
Scintillator	Density [g/cm <sup>3</sup> ]	X <sub>0</sub> [cm]	Light Yield γ/MeV (rel. yield*)	τ <sub>1</sub> [ns]	$\lambda_1$ [nm]	Rad. Dam. [Gy]	Comments
NaI (Tl)	3.67	2.59	4×10 <sup>4</sup>	230	415	≥10	hydroscopic, fragile
CsI (Tl)	4.51	1.86	5×10 <sup>4</sup> (0.49)	1005	565	≥10	Slightly hygroscopic
CSI pure	4.51	1.86	4×10 <sup>4</sup> (0.04)	10 36	310 310	10 <sup>3</sup>	Slightly hygroscopic
$BaF_2$	4.87	2.03	10 <sup>4</sup> (0.13)	0.6 620	220 310	105	
BGO	7.13	1.13	8×10 <sup>3</sup>	300	480	10	
PbW04	8.28	0.89	≈100	12222000	oad band oad band	104	light yield =f(T)

Characteristic parameters of some inorganic scintillators



Light emission spectra for some inorganic scintillator crystals [Ref. W.R. Leo]

#### Figures to Chapter 7.3



Emission spectra of a primary fluorescence material and a wavelength shifting material in comparison to the spectral sensitivity of the photo-cathode of a common photomultiplier [Ref. C. Grupen]

Important parameters of organic fluorescence materials and wavelength shifting materials. The quoted light vield is normalized to the one of NaJ (sodium iodide). [Ref. C. Grupen]

Abklingzeit

[ns]

96

30

5

1.2

1.6

1.2

Ausbeute

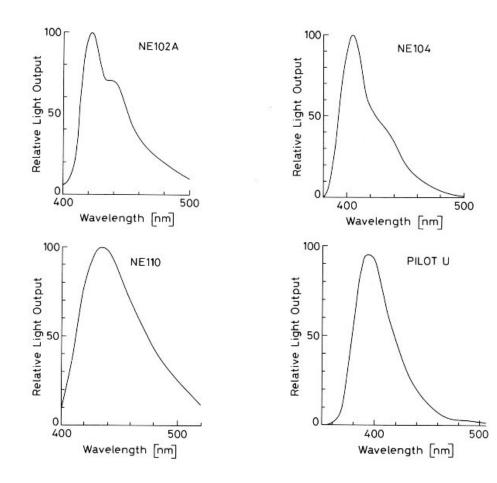
Ausbeute NaJ

0.12

0.5

0.25

Scintillator	$\sigma$ [ns]	τ [ns]
NE102A	0.7	2.4
NE111	0.2	1.7
Naton 136	0.5	1.87



Gaussian standard deviation and exponential decay constant for light pulses of frequently used plastic scintillators. [Ref. W.R. Leo] Light emission spectra of several frequently used plastic scintillators of the company *Nuclear Enterprises.* [Ref. W.R. Leo]

### Figures to Chapter 7.4

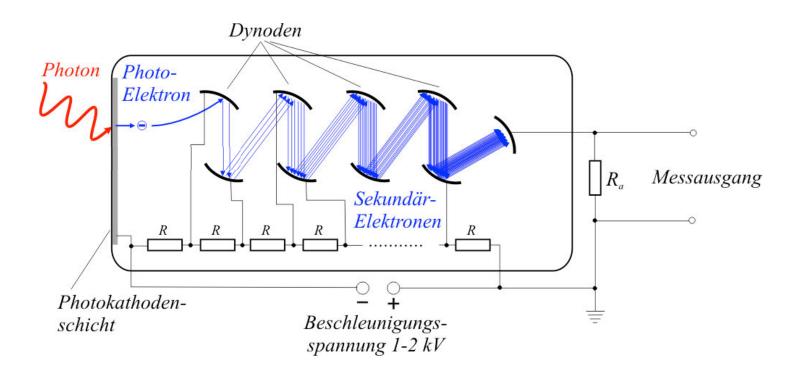


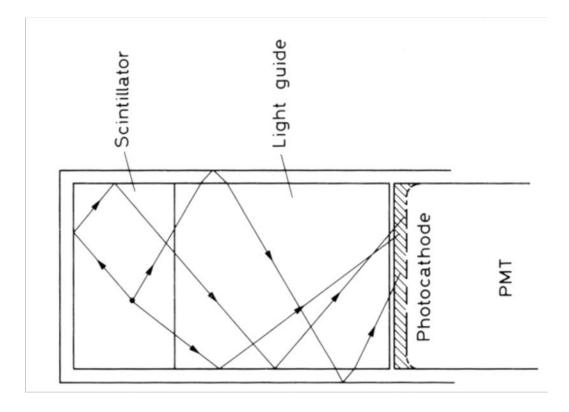
Illustration of the principle layout and of the mode of operation of a photomultiplier

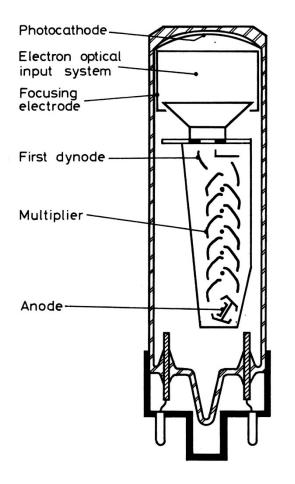


"Standard photomultiplier" for applications in detector physics

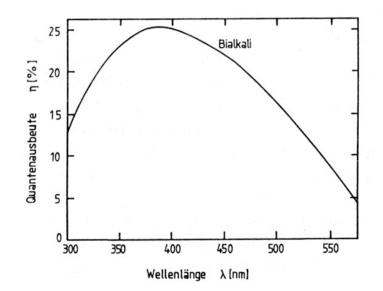


Variety of photomultipliers of the company Hamamatsu Photonics (Japan)



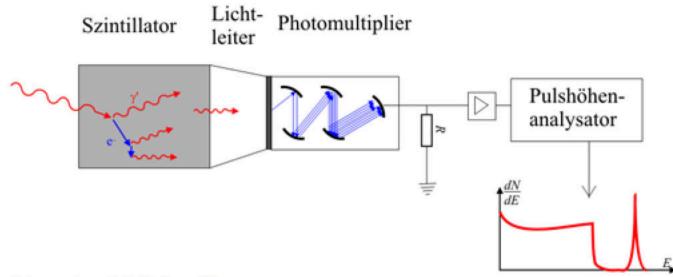


Schematic drawing of the layout of a photomultiplier [Ref. W. R. Leo]



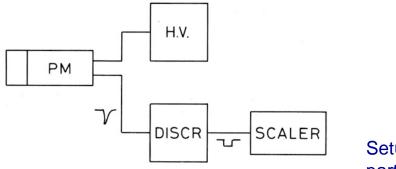
Quantum efficiency of a bi-alkali-cathode as a function of the wavelength [Ref. C. Grupen]

#### Figures to Chapter 7.5

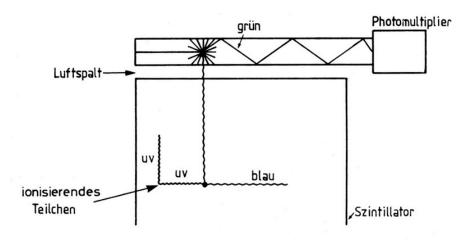


Schema eines Szintillationszählers

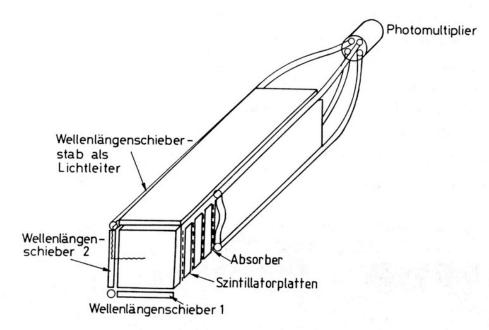
Typical setup for  $\gamma$ -spectroscopy using a scintillator and photomultiplier

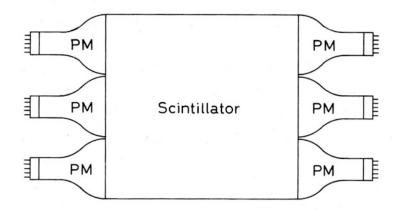


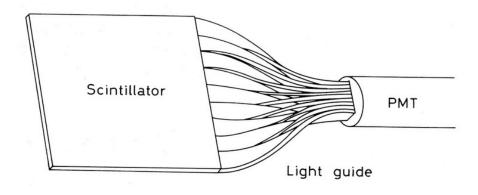
Setup of a counter to register particles using a scintillator



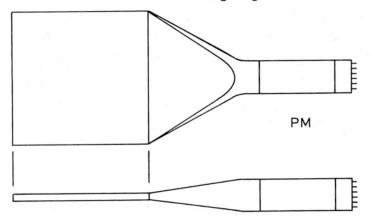
Principle of a calorimeter readout with a scintillator and a wavelength shifters



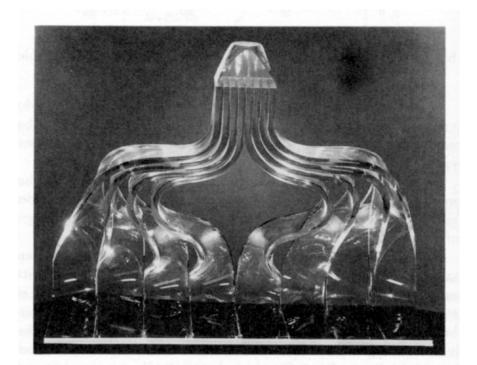


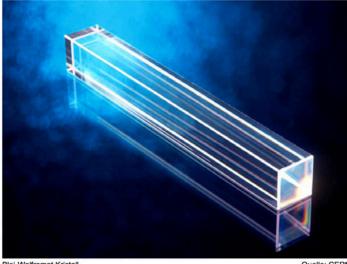


Light guide



Examples for the coupling of photomultipliers and scintillators via light guides

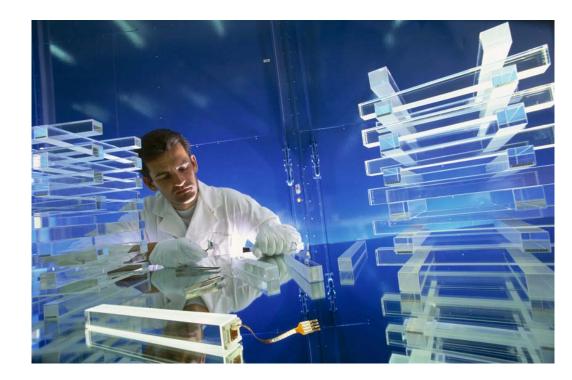




Blei-Wolframat Kristall

Quelle: CERN

Lead-tungstate scintillator crystal for the energy measurement in the calorimeter of the CMS experiment at the LHC





Calorimeter module of the UA2 experiments with plastic scintillators as active material

7.6 New photon-sensitive devices

- Avalanche Photon Diode (APD)

- Silicon Photomultiplier (SiPM)

# Why new devices?

## Pros and Cons for conventional photomultipliers

Pros:

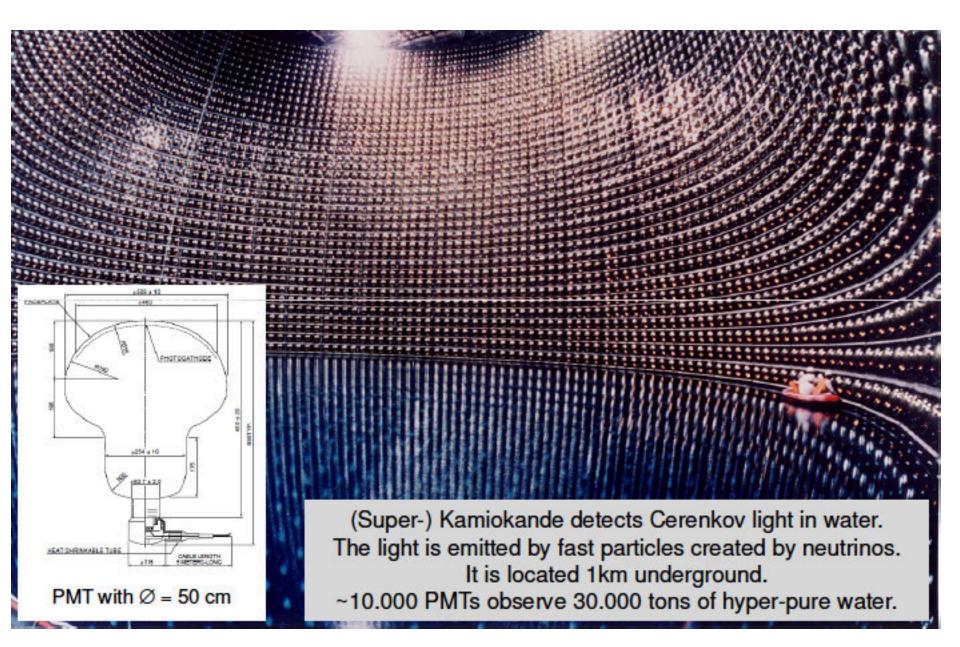
- Single photon sensitivity
- Low dark noise (signals with no photons)
- Sensitive from UV to IR light (depends on window and photocathode)
- Fast (rise time ~ns)
- Large areas can be covered (example: Super-Kamiokande, Japan)

### Cons:

- Mechanically sensitive (large, glass windows)
- Expensive / but not per area
- Need high voltage (kV) / large power (divider for dynode voltage)
- Large
- Sensitive to magnetic fields

(effect depends on orientation of the PM w.r.t. field)

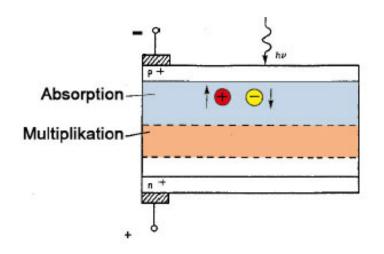
## Very large photomultipliers at Super-Kamiokande



# Avalanche Photodiode (APD)

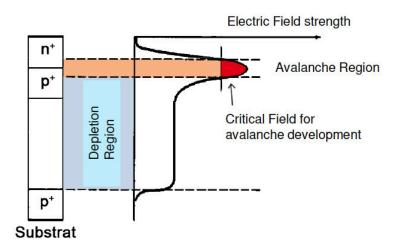
# **Basic Function:**

- -pn diode in reverse bias (partially or fully depleted)
- -Some potential for photon absorption
  - (The efficiency clearly depends on the material, layer thickness
  - and wavelength; proper materials for absorption in the range from 350 nm 100  $\mu$ m exist)
- -Per photon: electron-hole pair is created
- -Charge carriers are separated and drift to electrodes SPECIAL: a very high field accelerates the charge carriers so much that secondary carriers are created
  - $\rightarrow$  an avalanche develops  $\rightarrow$  amplification, large signals



## Avalanche Photodiode (APD) (cont.)

- The absorption / drift region should be thick
   → sensitivity increases with thickness
- A high-field region is created by a strongly doped pn-junction
  - \* High field must still be below Si-breakdown (3 x 10<sup>7</sup> V/m)
  - \* Typical field: ~10<sup>7</sup> V/m = 10<sup>5</sup> V/cm = 10 V/ $\mu$ m



- Difficult design / layout issues (high electric fields might appear at edge structures, guard rings (lower doped regions at the edge) needed

## **Operation modes of APDs**

### -Linear (Proportional) Mode

- \* Bias is below the breakdown voltage
- \* Moderate gain ~10 10<sup>3</sup>
- \* The signal is proportional to the number of photons; required e.g. in calorimetry (measured scintillation light)

### -Geiger Mode

- \* Bias voltage is (slightly) above the breakdown voltage
- \* Very high gain ~10<sup>6</sup>
- \* Signal becomes independent of primary number of photons
- \* Needs a so-called quenching circuit to lower the bias voltage after a hit to stop the avalanche
- \* APD (in this mode of operation) is insensitive after "quenching"

# Silicon Photomultiplier (SiPM)

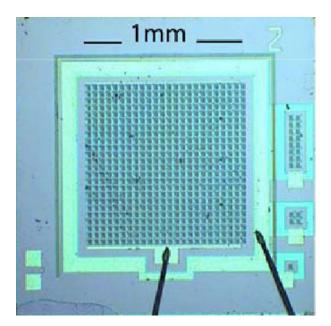
- Problem of APD: the gain is low in linear mode (which is often preferred, e.g. in calorimeter readout)
- → Use Geiger mode and use many APDs in parallel with separate quench circuits
   (essentially go to pixel structures of 50 x 50 μm<sup>2</sup> areas)

→ Each Single Photon APD (SPAD) works in Geiger mode

- Breakdown of a single SPAD creates only a small signal
- The total signal is proportional to the number of fired cells, (i.e. equal to the number of photons for low numbers, however, saturation effects expected)
- Such devices are called: SiPM (Silicon Photo Multipliers) MPPC (Multiple-Photon Pixel Counter) Si-SSPM (Silicon Solid State PMT)

### Silicon Photomultiplier (SiPM) (cont.)

- SPAD cell size is in the order of 50 x 50  $\mu$ m<sup>2</sup>  $\rightarrow$  10<sup>2</sup> – 10<sup>3</sup> SPADs per mm<sup>2</sup>
- Bias voltage typically 30-60 V
- Device area can be up to 8 x 8 mm<sup>2</sup>
   → more than 10.000 SPADs



### Photon detection efficiency of SiPMs

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700

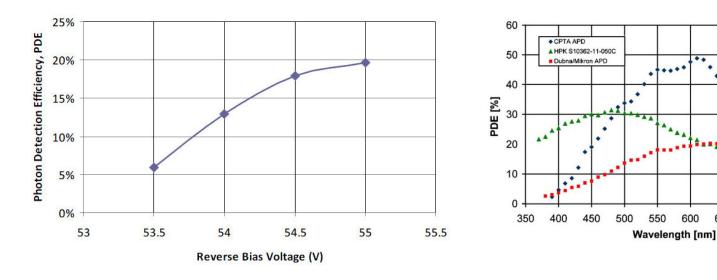
750

800

650

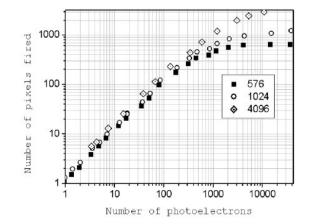
The fraction of detected photons depends on:

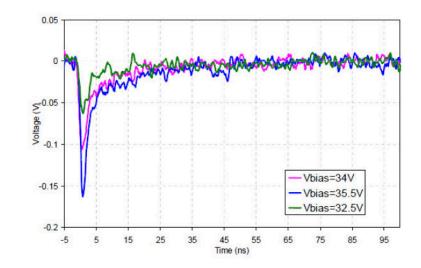
- Fraction of really sensitive area (cell boundaries, isolation, ..)
- Reflectivity of the surface (anti reflex coating ARC)
- Probability of photon absorption (depends on wavelength)
- Dead time after a pulse or a dark hit



### Additional features of SiPMs

- Non-linearities for large number of photons
  - Fired cells cannot fire again (within a short time)
    - → reduction of detected signal for many photons; largest signal is obviously = # of SPAD cells
- Temperature sensitivity: Breakdown voltage depends on temperature, temperature has to be controlled
- Very fast !
   Rise time < 1 ns</p>
   however, recovery time ~70 ns





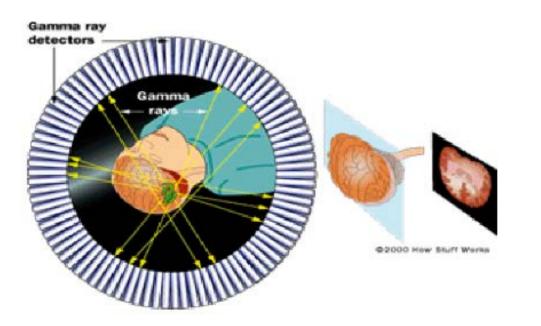
### Summary on SiPMs

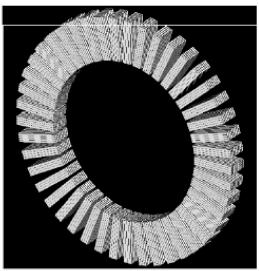
- Interesting new development First applications promising, however, more experience need to be gained
- Good sensitivity, however, lower than PMT
- Signal linear, however, saturation effect for large number of photons
- Insensitive to magnetic fields, low bias voltage, small devices and relatively cheap

- Larger dark noise as compared to PMT
- Control of temperature required

## A major application of SiPMs: Tomography (PET)

- Detection of scintillation photons (from 511 keV  $\gamma$ ) required
- Time resolution required
  - for coincidence:  $\sim 5 10$  ns
  - for time of flight: ~100 ps
- Compact
- Need to be operated in presence of large magnetic fields





Tomograghgeometrie mit 45 Detektormodulen